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M. Brunson

PATENT APPLICATION 7/22/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Group Art Unit: 2814

Application No.: 08/930,449

Examiner: S. Rao

Filed: October 7, 1997

Docket No.: JAO 39514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENTDirector of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee. Attached is our Check No. 132140 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.
- ☒ a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.
37 CFR §1.97(e)(1).
- ☒ 2. The references were cited in a counterpart foreign application Office Action.

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- ☒ 3. English-language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,



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JAO:DML/rxg

Date: July 3, 2002

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CONSIDERATION OF SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

On July 3, 2002, Applicants filed a Supplemental Information Disclosure Statement in the U.S. Patent and Trademark Office for the above-identified application. However, due to a typographical error, an incorrect patent application number appears on the front page of the Supplemental Information Disclosure Statement.

The filed Supplemental Information Disclosure Statement inadvertently is identified as belonging to patent application number 08/830,449, when it actually relates to the present application, 08/930,449.

In the event the Supplemental Information Disclosure Statement was associated with the Patent Office's file for Application No. 08/830,449, Applicants respectfully request that the Supplemental Information Disclosure Statement filed on July 3, 2002 be obtained from the file for Application No. 08/830,449, and be entered and considered in relation to the present application, 08/930,449.

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For the convenience of the Patent Office, an additional copy of the Supplemental Information Disclosure Statement, Form PTO-1449 and references is attached hereto.

As the Supplemental Information Disclosure Statement included a check for the appropriate fee, Applicants submit that no further fee should be due.

Should the Examiner have any questions concerning this or any other matter regarding the above-identified application, the Examiner is invited to contact Applicants' undersigned representative at the telephone number listed below.

Respectfully submitted,



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Date: July 11, 2002

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